Docket Number: 081468-0306525

Client Reference: P-1586.010-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

JOERI LOF, et al.

Application No.: 10/705,816

Filed: November 12, 2003

Group Art Unit: 2878

Examiner: Lu, Tony W.

Confirmation No.: 5408

For: LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD

APR 1 0 2006

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. One copy of each non-U.S. reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicant respectfully requests the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicant with the next Office communication to indicate that the references have been considered, per MPEP § 609.

This Information Disclosure Statement is being filed after the mailing of the first official action on the merits but before the mailing date of a Final Rejection or Notice of Allowance. Please charge Deposit Account 033975 in the amount of \$180.00 in payment of the fee under 37 CFR 1.17(p) pursuant to 37 CFR 1.97(c)(2). Please credit or debit Deposit Account 033975 as needed to ensure consideration of the disclosed information.

Respectfully Submitted,

Jean-Paul G. Hoffman Registration Number 42663

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Customer Number: 20090001

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Date: April 10, 2006

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P.O. Box 10500 McLean, VA 22102 Patent and Trademark Office



Atty.

Dkt. No.

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INFORMATION DISCLOSURE STATEMEN TRADEMINE

Applicant: LOF et al.

Applin. No. 10/705,816

Filing Date: November 12, 2003

Examiner: Waknown Zout / Group Art Unit: 2882

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*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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